

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: S.V. Sreenivasan et al.	Art Unit	: 1791
Serial No.	: 10/788,700	Examiner	: Matthew J. Daniels
Filed	: February 27, 2004	Conf. No.	: 6995
Title	: FULL-WAFER OR LARGE AREA IMPRINTING WITH MULTIPLE SEPARATED SUB-FIELDS FOR HIGH THROUGHPUT LITHOGRAPHY		

**Mail Stop AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

In response to the Office Action having a mailing date of May 27, 2008, with a three-month shortened statutory period set to expire on August 27, 2008, please amend the above identified application as follows: